

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention	SEMICONDUCTOR DEVICE AND FABRICATION PROCESS THEREFOR
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Application Number :

Confirmation Number:

First Named Applicant: Lloyd Burrell

Attorney Docket Number: FIS920030011US1

Art Unit:

Examiner:

Search string: (5391516 or 6350667 or 5523626 or 20020068385 or 20010051426).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
P.M	1	5391516	1995-02-21	WOJNAROWSKI, ET AL.			
A.M	2	6350667	2002-02-26	CHEN, ET AL.			
A.M	3	5523626	1996-06-04	HAYASHI, ET AL.			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
A.M	1	20020068385	2002-06-06	MA, ET AL.			
A.M	2	20010051426	2001-12-13	POZDER, ET AL.			

Signature

Examiner Name	Date
ANH D. Mai	10/05/04

